AMENDMENST TO THE CLAIMS

- 1.-7. (Canceled)
- 8. (Currently Amended) An apparatus, comprising:
- a heat spreader comprising heat conductive material and a contiguous wall structure extending from a surface of the heat spreader;
 - a package substrate;
- a flexible material in contact with the surface of the heat spreader and the package substrate, the flexible material defining a perimeter of a cavity; and
 - a circuit substrate disposed within the cavity.
- 9. (Previously Presented) The apparatus of claim 8, wherein the flexible material comprises polymeric sealant material.
- 10. (Previously Presented) The apparatus of claim 8, wherein the heat spreader is plated with nickel.
- 11. (Previously Presented) The apparatus of claim 8, wherein the heat spreader is coated with a heat-conductive organic material.
- 12.-17. (Canceled)
- 18. (Previously Presented) A semiconductor package, comprising:
 - a substrate having a surface;
 - at least one semiconductor device coupled to the surface of the substrate;
- a cover coupled to the surface of the substrate through a flexible sealant material, the flexible material contacting a surface of the cover and the surface of the substrate and creating a space between the substrate and the cover, the semiconductor device residing within the space, and the cover comprised of a heat-conductive material; and
- a thermal interface material comprising metal particles disposed between a surface of the semiconductor device and the surface of the cover,

wherein the cover comprises a contiguous attachment structure extending from the surface into the flexible material.

- 19. (Original) The semiconductor package of claim 18, wherein the cover is a heat spreader.
- 20.-23. (Canceled)
- 24. (Previously Presented) The apparatus of claim 8 further comprising:
 a thermal interface material comprising metal particles disposed between a surface of the circuit substrate and the surface of the heat spreader.

Respectfully submitted,

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